



2814 BOX AF AF

<b>TRANSMITTAL LETTER</b> (General - Patent Pending)	<b>RECEIVED</b>	Docket No. IIZ.008D
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In Re App. No. Of: Jun KANAMORI

MAY 11 2001

TC 2800 MAIL ROOM

Serial No. 09/398,189	Filing Date September 17, 1999	Examiner S. Rao	Group Art Unit 2814
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Title: **METHOD OF FABRICATING A SEMICONDUCTOR DEVICE WITH SELF-ALIGNED SILICIDE AREAS FORMED USING A SUPPLEMENTAL SILICON OVERLAYER**

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

**REQUEST FOR RECONSIDERATION**

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. **50-0238** as described below. A duplicate copy of this sheet is enclosed.
- ☐ Charge the amount of \_\_\_\_\_
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.

\_\_\_\_\_  
Signature

Dated: May 9, 2001

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I certify that this document and fee is being deposited on \_\_\_\_\_ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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Signature of Person Mailing Correspondence

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